

## Pneumatic drive bellows pumps

For high purity chemical handling applications in semiconductor processing applications

The Heart of Industry

### For high purity chemical handling applications in semiconductor processing applications

The F-Series includes pneumatic drive bellows pumps that are designed for use in the semiconductor manufacturing processes. Iwaki introduced the first designs over 20 years ago and has continually developed new products to keep up with rapidly changing market needs. With over 20 different models available the quality and performance of our products has made them the preferred solution by device manufactures all over the world. Their quality and performance are recognized and highly rated by device manufactures all over the world.

We offer not only pump solutions, but also accessories including controllers, dampeners, and liquid chemical supply systems that have been developed to compliment a comprehensive portfolio of quality equipment for wet process and surface preparation applications.



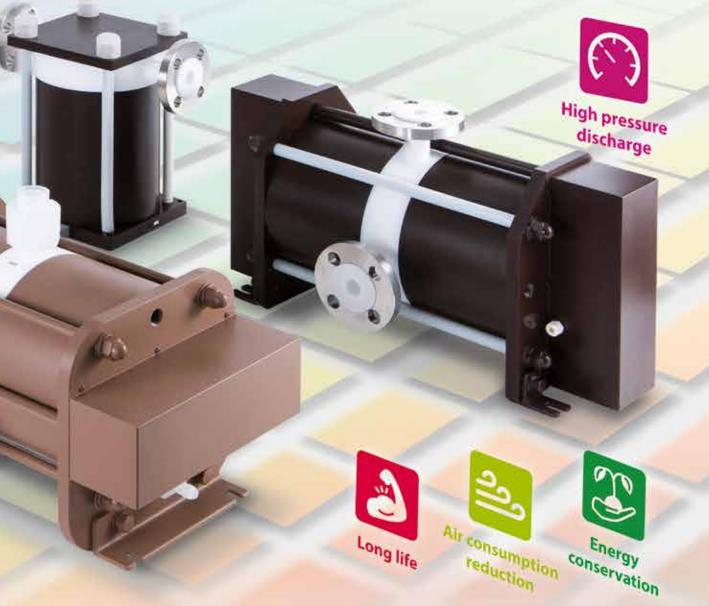
#### Guideline for pump selection

Max. d	discharge	capacity (L/min)	Max. supplie	d air pr <mark>ess</mark>	sure (MPa)		Max. air co	onsumption (NL	/min)		Tempera	ature range (	°C)
		55	0.5	5				670		1	80 - 5		
100			0.5	5			1210			18	0 - 10		
100			0.7			1495						60 - 5	
	80		0.5	5				820			10	0 - 10	
		40	0.5	5				480		18	0 - 10		
		22		0.3					180		1	00 - 5	
		40			0.2				200	180	- 20		
		40		0.4					200		1	00 - 5	

Note: Please check the specifications of each pump for liquid temperature and maximum supply air pressure.

Applications		$lacksquare$ : Usable $\bigcirc$ : Usable depend on condition								
Model		FS-H	FS-N	FW	FW-H	FF	FF-H	FA	CFD	
Wafer wet-bench	Cleaning (Batch process)	•	•	•	•	•	•	•		
water wet-bench	Cleaning (Single wafer)	•	•	•	•	•	•		—	
Chemical supply e	quipment	•	•	•		0		0	—	
CMD	Mixed-liquid circulation/Transfer	•	•	•		0		0	_	
CMP process	Cleaning	•	•	•		•	—	•		
Chemical replenish	nishing equipment					•				

Note: Liquid temperature conditions vary depending on pump specifications.



Model		Page				Page
FS-15/30/60H	Small & lightweight Low cost High temperature transfer Long life	3		Performa	nce curves	9 - 10
FS-100H	High temperature transfer Large flow transfer	4	Dumm identification		Dampener	11 - 12
FS-N	Small & lightweight Low cost High pressure discharge Large flow transfer	5	Pump identification,	Ontions	Quick exhaust valve	13
FW	High pressure discharge Long life	6	Construction	Options	Pump controller /	12
FW-H	High temperature transfer High pressure discharge Long life	6	and materials,		Pump driver	13
FF	Air consumption reduction Energy Conservation	7	Specifications,		Chemical replenishing system	14
FF-H	High temperature transfer Air consumption reduction Energy Conservation	7	Dimensions			
FA	Long life	8				

# FS-15/30/60H

### A small, lightweight and cost effective solution

• Using a higher stroke rate (240 spm maximum) has resulted in a reduction in size, weight and cost.

Note: The maximum stroke rates are dependent on model and application; please refer to the specification table for details.

- All liquid contact components are constructed of high purity fluororesin materials. The exterior of the units are also coated in fluororesin so that no metallic components are exposed. FS-H pumps also utilize our own shaft seal design (patent pending) resulting in a marked reduction in particle generation.
- The pumps are rated for liquid temperatures ranging from 5 180 °C with discharge pressure to 0.45 MPa. Applications include wet process circulation and CMP pro-cesses, as well as chemical distribution feed systems.
- The pump uses a proximity sensor drive system which opens/closes an external air solenoid valve providing easy performance control capabilities that are compatible with a variety of controller options.



weight

ture transfer

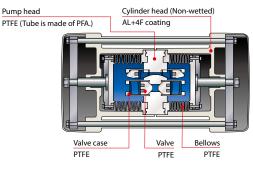


#### **Pump identification**

	FS	-	15	Н	Т	1	-	01
	1		2	3	4	5		6
1 Series code					4 Pump	o conne	ction	(suction

- 2 Pump size
- 15 : Max. discharge capacity 15L/min
- 30 : Max. discharge capacity 30L/min
- **60** : Max. discharge capacity 55L/min
- 3 Liquid temperature
- **H** : High liquid temperature (5 180°C)
- 4 Pump connection (suction/discharge)  $\mathbf{T}$ : Tube connection
- 5 Sealing structure of pump head/bellows 1: Bellows separation type
  - 2 : Welded one-piece structure
- 6 Special specification Without code : Standard specification 01 (Serial number) : Special specification

#### **Construction and materials**



#### Specification

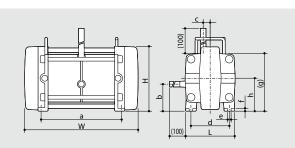
Model			FS-15HT1/T2			FS-30HT1/T2		FS-60HT/T2			
Max. discharge capacity	L/min		15		30			55			
Air supply pressure range	MPa	0.15 - 0.5	0.15 - 0.3	0.15 - 0.2	0.15 - 0.5	0.15 - 0.3	0.15 - 0.2	0.15 - 0.5	0.15 - 0.3	0.15 - 0.2	
Liquid temperature range	°C	5 - 50	51 - 100	101 - 180	5 - 50	51 - 100	101 - 180	5 - 50	51 - 100	101 - 180	
Max. air consumption	NL/min	200	160	110	370	280	170	670	440	300	
Max. stroke speed Note	spm	Max. 240				Max. 220			Max. 200		
Pump connection size			1/2" PFA tube		Ø19	Ø19ר16mm PFA tube			Ø25ר22mm PFA tube		
Supply air connection size			Rc1/4			Rc1/4			Rc3/8		
Ambient temperature	°C		0 - 40			0 - 40			0 - 40		
Drive system		By proximity switch			By proximity switch			By proximity switch			

Note: 180 spm maximum with feed air pressures between 0.3 and 0.5 MPa.

Max. discharge capacity shows when pumping clear water at 20°C.

#### **Dimension in mm**

Model	W	L	Н	а	b	с	d	e	f	g	h
FS-15HT1/T2	315	120	166	213	77	15.5	96	10	8	144	84
FS-30HT1/T2	390	151	208	272	93	23	115	10	9	180	105
FS-60HT1/T2	441	194	251	317	107	27	152	12	11	224	127



# **FS-100H**



ture transfer tra

transfer

## Flow and temperature capabilities offer improved process efficiencies

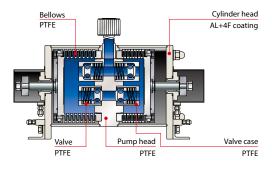
- Maximum flow rate of up to 100 L/min with 180°C liquid. This allows delivery of CARO (SPM) or H3PO4 at a flow rate 1.8 times higher than our existing pumps (55 L/min).
- Higher flow rates improve cleaning efficiency and removal of containments during wafer processing. Cleaning times are also reduced in systems with multiple processing lines.
- In addition to the use of fluoroplastic wet ends (PTFE and PFA), a fluorine coating on the pump's outer surfaces offers the best resistance to vapors from acid, alkali and hydrogen peroxide chemistries used in semiconductor manufacturing.
- Optimization of design has resultind in reduced weight of about 15% of our existing 80-100L models making installation and replacement work easier.
- The pump uses a proximity sensor drive system which opens/closes an external air solenoid valve providing easy performance control capabilities that are compatible with a variety of controller options.



FS	-	100	Н	Т	2	-	01
1		2	3	4	5		6

- 1 Series code
- 2 Pump size 100 : Max. discharge capacity 100L/min
- 3 Liquid temperature H : 10 - 180°C
- 4 Pump connection (suction/discharge)
   T : Tube connection
- 5 Sealing structure of pump head/bellows2 : Welded one-piece structure
- 6 Special specification
   Without code : Standard specification
   01 (Serial number) : Special specification

#### **Construction and materials**

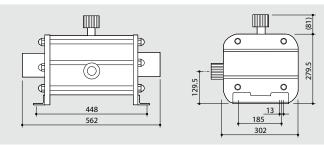


#### Specification

Model			FS-100HT2					
Max. discharge capacity	L/min	min 100						
Air supply pressure range	MPa	0.15 - 0.5	0.15 - 0.4	0.15 - 0.3				
Liquid temperature range	°C	10 - 100	101 - 140	141 - 180				
Max. air consumption	NL/min	1210						
Max. stroke speed Note	spm	Max. 120						
Pump connection size		1 1/4" fittings (Sl tured by N	JPER 300-type PILLAF lippon Pillar Packagin	R FITTING manufac- g Co., Ltd.)				
Supply air connection size		Rc1/2						
Ambient temperature	°C	0 - 60						
Drive system		By proximity switch						

Max. discharge capacity shows when pumping clear water at 20°C.

#### **Dimension in mm**



# FS-N



## Max. 100L/min. High flow design for chemical distribution applications

• Perfectly suited to high flow & pressure chemical distribution requirements.

- The high stroke rate (Max 200 SPM:FS-80NT) provides for a compact, lightweight and lower cost option without sacrificing flow and pressure capability.
- All liquid contact materials are made of high purity fluororesin resulting in contamination-free construction. Our unique patented shaft seal (FS- 80NT...PAT.) also dramatically reduces particle generation.
- The pump utilizes a built in proximity sensor driven control system to switch an
  external air solenoid valve. Leak sensors are also included as standard equipment.
- Seal welded pump head and bellows eliminate leakage.



#### **Pump identification**

FS	-	80	Ν	Т	-	01
1		2	3	4		5

- 1 Series code
- 2 Pump size
  - 80 : Max. discharge capacity 80L/min100 : Max. discharge capacity 100L/min
- 3 Liquid temperature N: 5-60°C
- T : Tube connection
   F : Flange connection
   Sealing structure of pump head/bellows:

4 Pump connection (suction/discharge)

- Welded one-piece structure
  5 Special specification
  - Without code : Standard specification **01** (Serial number) : Special specification

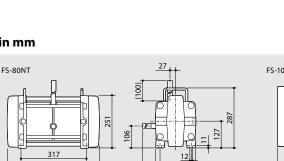
#### Specification

Model			FS-80NT		FS-100NF
Max. discharge capacity	L/min		80		100
Air supply pressure range	MPa	0.2 - 0.5	0.2 - 0.7		
Liquid temperature range	°C		5 - 60		
Max. air consumption	NL/min	1029	938	787	1495
Max. stroke speed	spm	Max. 200	Max. 150	Max. 110	Max. 100
Pump connection size		Ø25	JIS 20K 25A Flange		
Supply air connection size			Rc3/8		Rc1/2
Ambient temperature	°C		0 - 40		
Drive system		Ву	By proximity switch		

• Max. discharge capacity shows when pumping clear water at 20°C.

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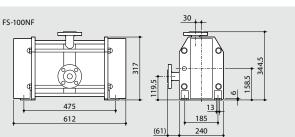
#### **Dimensions in mm**



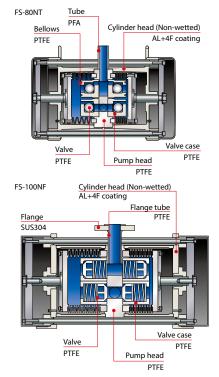
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194



#### **Construction and materials**



## FW/FW-H





Long life

## Robust bellows design provides for high pressure capability and extended service life

• The use of a thick bellows increases the pumps discharge pressure rating to as high as 0.45 MPa maximum.

In addition, the bellows have three to four times longer service life than a diaphragm. This results lower case a substantially reduced downtime.

- This design is commonly used for chemical feed, the FW series can be used in high pressure and medium temperature (10 100 °C) cleaning systems as well as for the circulation of CMP slurry liquids. The FW-H with its higher temperature capability (10 180 °C) is ideal for chemical circulation in wafer cleaning applications.
- Easily adaptable fitting capability, the internally formed PFA suction and discharge tubes prevent the accumulation of particles.
- When connected to a special controller, the discharge can be monitored and controlled easily.
- The pump utilizes a built in proximity sensor driven control system to switch an external air solenoid valve. Leak sensors are also included as standard equipment.



	FW	-	20	Н	Т	1	-	01	
	1		2	3	4	5		6	
1 Series code					4 Pump	conne	ection	(suction/d	ischarge)

T: Tube connection

6 Special specification

1 : Bellows separation type

2 : Welded one-piece structure

5 Sealing structure of pump head/bellows

Without code : Standard specification

01 (Serial number) : Special specification

- 2 Pump size
- 20 : Max. discharge capacity 20L/min
- 40 : Max. discharge capacity 40L/min
- 80 : Max. discharge capacity 80L/min
- 3 Liquid temperature Without code : Medium-liquid temperature (10 - 100°C)
  - ${f H}$  : High liquid temperature (10 180°C)

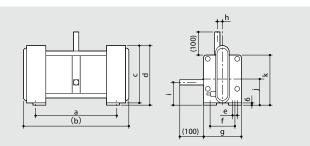
#### Specification

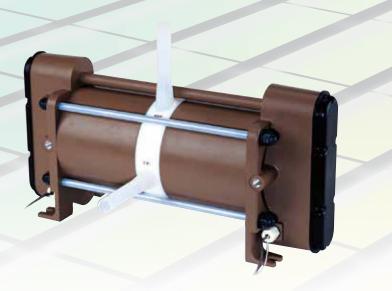
operintation										
Model		FW-20	FW-40	FW-80		FW-20H			FW-40H	
Max. discharge capacity	L/min	20	40	80	20			40		
Air supply pressure range	MPa		0.2 - 0.5		0.2 - 0.5	0.15 - 0.3	0.15 - 0.2	0.2 - 0.5	0.15 - 0.3	0.15 - 0.2
Liquid temperature range	°C	10 - 100	10 - 100	10 - 80	10 - 100	101 - 150	151 - 180	10 - 100	101 - 150	151 - 180
Max. air consumption	NL/min	330	480	820	330	200	140	480	300	220
Max. stroke speed Note	spm	Max. 120	Max. 80	Max. 80		Max. 120		Max. 80		
Pump connection size	mm	Ø19ר16 PFA tube	Ø25ר22	2 PFA tube	Ø	019ר16 PFA tu	be	Ø	025ר22 PFA tul	be
Supply air connection size		Rc1/4	Rc3/8	Rc1/2		Rc1/4			Rc3/8	
Ambient temperature	°C		0 - 40		0 - 40 0 - 40					
Drive system		By	proximity swit	ch	By proximity switch By proximity switch			ch		

Max. discharge capacity shows when pumping clear water at 20°C.

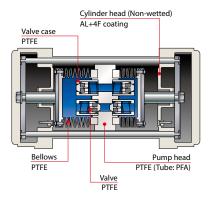
#### **Dimensions in mm**

Model	a	(b)	с	d	e	f	g	h	i	j	k
FW-20/20H	347	458	218	221	10	105	140	22	90	112	182
FW-40/40H	435	542	240	250	12	143	183	25.5	102	130	220
FW-80	464	600	302	317	13	185	240	27	119.5	158.5	317





#### **Construction and materials**



# FF/FF-H





High temperature transfer

1 Series code

2 Pump size

FF-H : High-liquid temperature (20 - 180°C)

20 : Max. discharge capacity 20L/min

40 : Max. discharge capacity 40L/min

Air consumption reduction

Energy conservation

### Energy efficient design consumes less air

- The FF series is designed for use with medium temperature liquids (Al cylinder type: 5 to 100°C, PVC cylinder type: 5 to 50°C) and the FF-H series is designed for temperatures ranging from 20 to 180°.
- All liquid contact components are constructed of high purity fluororesin materials with no metal or elastomers. The bellows are welded to the center eliminating leaks associated with heat cycles. The efficient design minimizes dead air volume surrounding the bellows to minimize air consumption.
- Suction and discharge fluid connections are PFA tubes and for FF models PFA tubes with special fittings are available.
- The pump utilizes a built in proximity sensor driven control system to switch an
  external air solenoid valve. Leak sensors are also included as standard equipment.



#### **Pump identification**

	FF	-	20	В	Т	1	-	01	
	1		2	3	4	5		6	
1 Series code					4 Pump	conne	ection	(suction/	discharge)
FF : Mediun	n-liquid	temp	erature (	5 - 100°C	) <b>T</b> : T	ube co	nnecti	ion	

- 2 Pump size
- 10 : Max. discharge capacity 10L/min 20 : Max. discharge capacity 22L/min
- 3 Cylinder material B : Al+4F coating
  - **B** : AI+4F C **C** : PVC

- 5 Sealing structure of pump head/bellows1 : Bellows separation type
- 6 Special specification
   Without code : Standard specification
   01 (Serial number) : Special specification

FF	-	20	Н	т	-	01
1		2	1	3		4

Valve cas

Bellows

PTFE

PTFF

3 Pump connection (suction/discharge)

**Construction and materials** 

Valve

PFA

AL+4F coating

Cylinder head (Non-wetted)

T: Tube connection Sealing structure of pump head/bellows: Welded one-piece structure

4 Special specification
 Without code : Standard specification
 01 (Serial number) : Special specification

Pump head

PTFE (Tube: PFA)

#### Specification

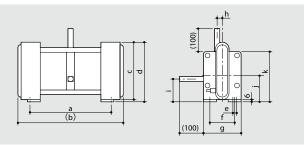
Model		FF-10BT/CT1	FF-20BT/CT1	FF-20HT	FF-40HT1
Max. discharge capacity	L/min	10	22	20	40
Air supply pressure range	MPa	0.15 - 0.3	0.15 - 0.3	0.15 - 0.2	0.15 - 0.2
Liquid temperature range	°C	B type: 5 - 100,	C type: 5 - 50 <sup>Note</sup>	20 - 180	20 - 180
Max. air consumption	NL/min	90	180	150	200
Max. stroke speed	spm	Max. 120	Max. 120	Max. 120	Max. 80
Pump connection size		1/2" PFA tube	3/4" PFA tube	3/4" PFA tube	Ø25ר22mm PFA tube
Supply air connection size		Rc1/4	Rc1/4	Rc1/4	Rc3/8
Ambient temperature	°C	0 - 40	0 - 40	0 - 40	0 - 40
Drive system		By proximity switch	By proximity switch	By proximity switch	By proximity switch

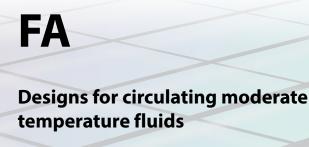
Note: The cylinder of the "B" type is made a damain and tetrafluororesin and that of the "C" type is of PVC.

Max. discharge capacity shows when pumping clear water at 20°C.

#### **Dimension in mm**

Model	a	(b)	с	d	e	f	g	h	i	j	k
FF-10	266	361	188	191	10	84	114	14.5	82	97	154
FF-20/20H	288	400	218	221	10	105	140	20	91/80	112	182
FF-40H	431	533	240	250	12	143	183	23.5	97	130	220





• There are two standard models available In the FA series; the FA-2E, a horizontal type for lower flow requirements and the FA-40VEW, a vertical type for a higher flow rates. A typical application for the FA-2E is in a spray system for single wafer processing while the FA-40VEW is suitable for batch cleaning of 200/300 mm wafers.

- The FA-40VEW is designed for a long service life and uses a robust bellows design suitable for continuous operation at higher discharge pressures.
- Discharge rates can be easily monitored and controlled when used with a dedicated controller
- The pump utilizes a built in proximity sensor driven control system to switch an external air solenoid valve. Leak sensors are also included as standard equipment.



#### **Pump identification**

FA	-	2	E-1	-	01
1		2	3		4

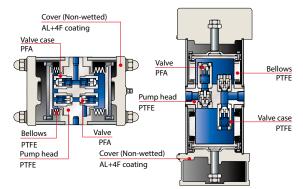
- 1 Series code
- 2 Pump size
- 2 : Max. discharge capacity 2L/min
- 40 : Max. discharge capacity 40L/min
- 4 Special specification Without code : Standard specification 01 (Serial number) : Special specification



- FA-2
  - -1: Air pulse timer switching valve system+Electrodes
  - E-1 : Controller system+Electrodes • FA-40

  - **VEW** : Controller system+Electrodes Pump head and bellows welded into one piece

#### **Construction and materials**



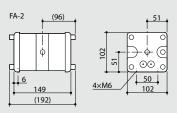
#### Specification

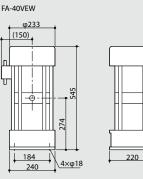
Model		FA-2E-1	FA-40VEW
Max. discharge capacity	L/min	2	40
Air supply pressure range	MPa	0.2 - 0.4	0.1 - 0.4
Liquid temperature range	°C	5 - 100	5 - 100
Max. air consumption	NL/min	50	200
Max. stroke speed	spm	Max. 150	Max. 80
Pump connection size		Rc1/8	Rc1
Supply air connection size		Rc1/4	Rc3/8
Ambient temperature	°C	0 - 40	0 - 40
Drive system		By proximity switch	By proximity switch

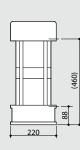
• Max. discharge capacity shows when pumping clear water at 20°C.

#### **Dimension in mm**

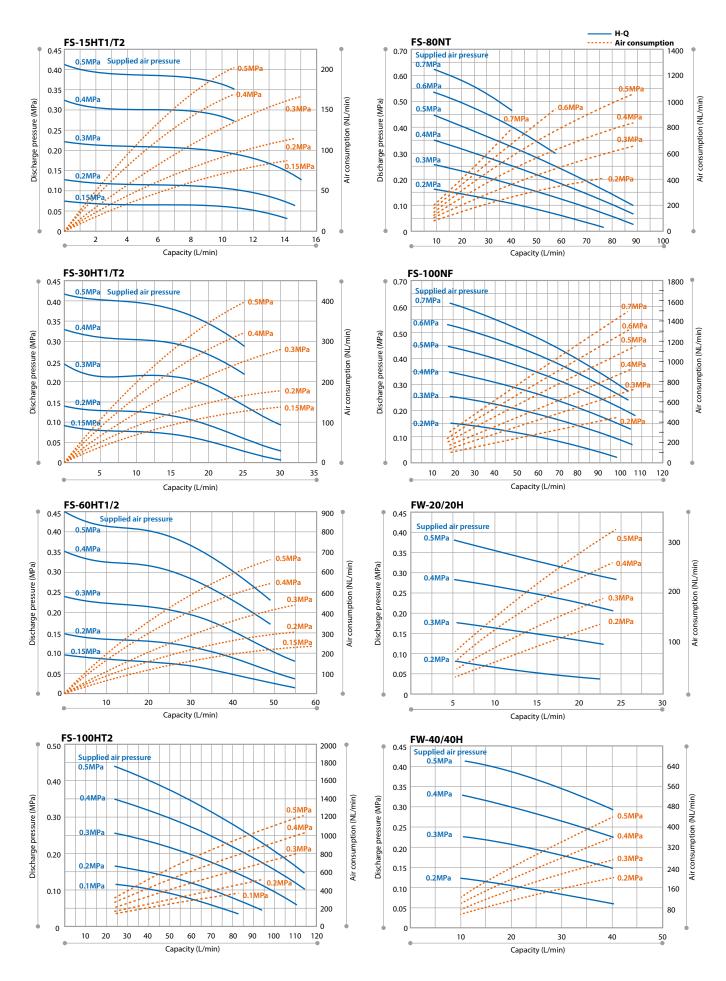
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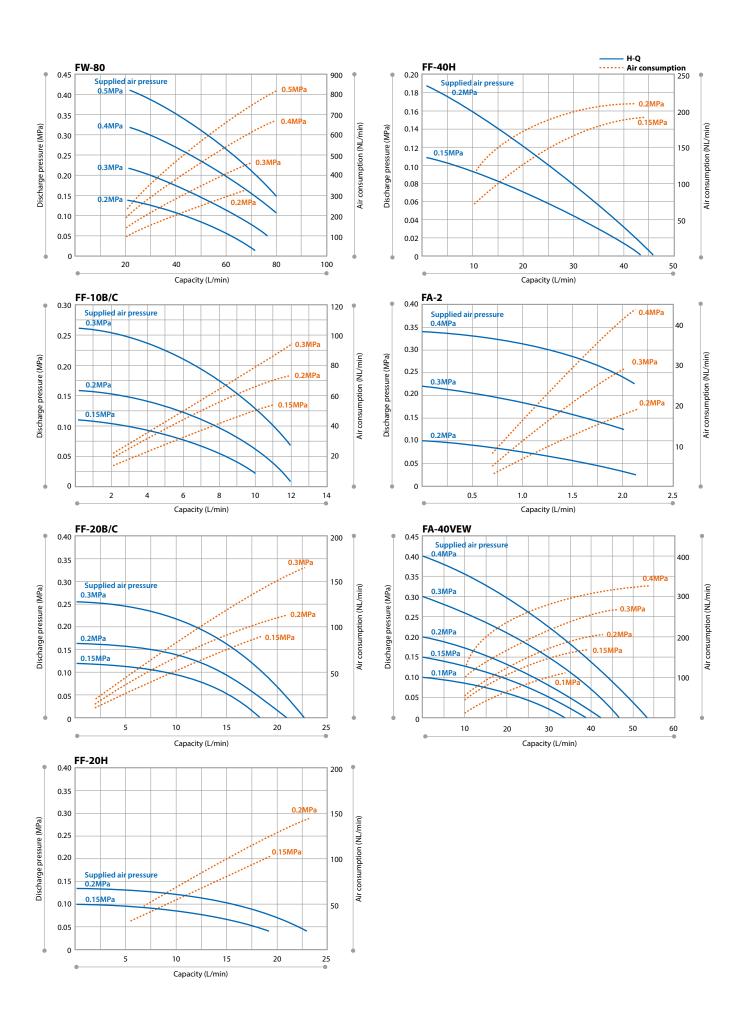






#### **Performance curves**





#### Options



#### Dampener

The Installation of a dampener on the discharge side of the pump will reduce pulsation and prevent particle release through filters as well as from pipe vibration.

#### Automatic dampeners PDA-H1/WB/W

- FS-H FW FW-H FF FF-H Automatic pressure adjustment minimizes downtime, eliminates manual adjustments.
- •Liquid inside the bellows can be easily drained. (PDA-WB/W model)



● The PDA-H1 is a medium pressure design for use with the FF, FF-H, and FA pumps. The PDA-WB/W is a high-pressure design

suitable for use with the FW, FW-H, and FS-H pumps. Typical applications include drug delivery and dispensing.

- The PDA-WB/W includes a leak sensor as standard. (For the PDA-H1, a leak sensor is available through special order.)
- For the PDA-WB/W, only the specified liquid pipe joint can fit the model. Please contact us before use to check if your joint is applicable.

#### Automatic dampeners PDA-100WBN

#### For the FS-100NF only

- Automatic pressure adjustment minimizes downtime, eliminates manual adjustments.
- Dampener pressure is automatically adjusted to the minimum pulse pressure even if the pump discharge load changes due to a clogged filter. The unit prevents particles being released from the filter and the pimping vibration.
- A leak sensor is included as a standard.

#### Pulse dampeners PD-H (for wet use)

#### for the FS-H only

- No automatic pressure adjustment.
- A low cost and compact dampener.
- Liquid inside the bellows can be easily drained.
- A leak sensor is included as a standard.

#### **Pulse dampeners PD-H1**

FF FF-H FA

- No automatic pressure adjustment.
- The PD-H1 is a medium-pressure design for use with FF, FF-H and FA pumps.

\* Models with leak sensors are available through special order.



	PDA-2	WB/W	PDA-80WB/W		
		FW-80			
°C	10 - 100	101 - 150	151 - 180	10 - 80	
MPa	0.5	0.3	0.2	0.5	
MPa	Less than 0.06 Note				
	1/2" PFA tube				
	Rc1/4				
	PTFE/PFA				
	MPa	FW-20/FW-20           FW-40/FW           °C         10 - 100           MPa         0.5           MPa         1/2"	FW-20/FW-20H, FS-15/FS-30 (F FW-40/FW-40H/FS-60 (PDA           ℃         10 - 100         101 - 150           MPa         0.5         0.3           MPa         1/2"         PFA tube           PFA tube         Rc	MPa         0.5         0.3         0.2           MPa         Less than 0.06 <sup>Note</sup> 1/2"         925ר22mm           PFA tube         Rc1/4         Rc1/4	

Note: In case that liquid viscosity is less than 1 - 50 mPa·s. • Cannot be used above the working pressure of the pump.

• The pulsating pressure range depends on the operating conditions. Please contact us for details. • There are some fittings that cannot be used. Please contact us for details.

Model		PDA-100WBN
Applicable pumps		FS-100NF
Liquid temperature range	°C	5 - 60
Max. supplied air pressure	MPa	0.7
Supply air pressure range	MPa	0.2 - 0.7
Pulsation pressure range	MPa	0.15 <sup>Note</sup>
Connection size		JIS 20K 25A Flange
Supply air connection size		Rc1/4
Wet-end materials		PTFE

Note: In case that liquid viscosity is less than 1 - 50 mPa-s.

• The maximum working fluid pressure is the pressure generated when the discharge side is closed. Please contact us for dampers for FS-80NT.

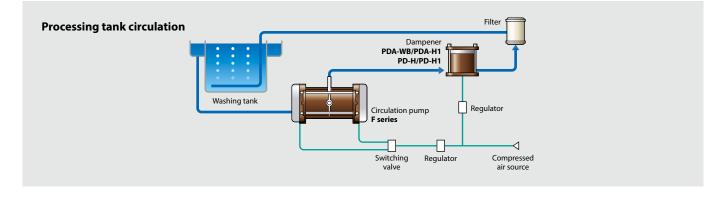
Model		PD-	15H	PD-	30H	PD-60H	
Applicable pumps		FS-15H	HT1/T2	FS-30H	HT1/T2	FS-60HT1/T2	
Liquid temperature range	°C	5 - 100	101 - 180	5 - 100	101 - 180	5 - 100	101 - 180
Max. supplied air pressure	MPa	0.3	0.2	0.3	0.2	0.3	0.2
Supply air pressure range	MPa	0.15 - 0.3	0.15 - 0.2	0.15 - 0.3	0.15 - 0.2	0.15 - 0.3	0.15 - 0.2
Pulsation pressure range	MPa			Less than 0.06 Note			
Connection size		1/2" PFA tube		3/4" PFA tube		Ø25ר22mm PFA tube	
Supply air connection size		Rc1/8					
Wet-end materials				PTFE	, PFA		

Note: In case that liquid viscosity is less than 1 - 50 mPa-s.

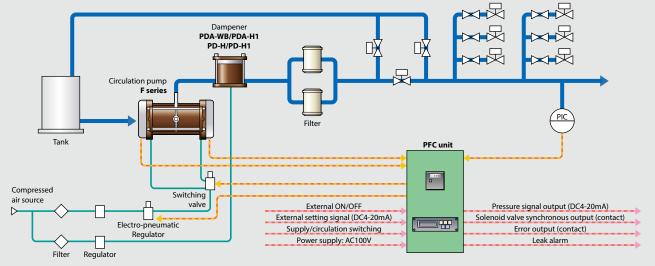
Cannot be used above the working pressure of the pump.

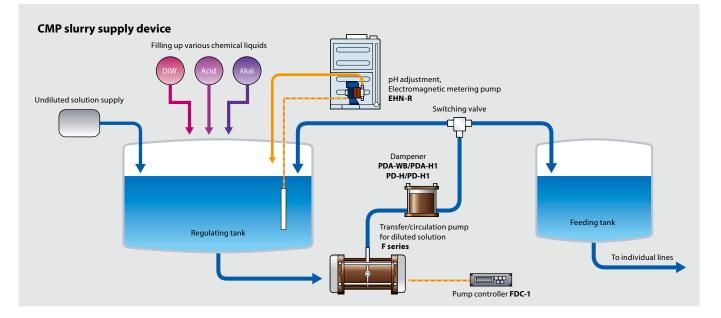
Model		PDA/PD-10H1 PDA/PD-20H1		PDA/PD-40H1		
Applicable pumps		FF-10B/CT1 FF-20B/CT1 FF-20HT		FA-40VEW FF-40HT1		
Liquid temperature range	°C	20 - 180				
Supply air pressure range	MPa	0	0.4			
Pulsation pressure range	MPa	Less than 0.04				
Connection size		1/2" PFA tube	3/4" PFA tube	Ø25ר22mm PFA tube		
Supply air connection size		Rc1/4				
Wet-end materials		PTFE/PFA				

#### **Example of installation**



#### Chemical supply unit (constant pressure control)





#### Options

#### Quick exhaust valve

When installed on the air exhaust lines at the pump the exhaust valve will help to reduce pulsation and prevent particle release from the filter as well as from pipe vibration.

#### QEV

Quick exhaust valves should be installed between the pump and the external solenoid valve. This helps to prevent corrosion of the solenoid valve from return air. It also reduces exhaust resistance to allow the bellows to move smoothly through each cycle.



Model	Connec- tion size	Applicable pumps
QEV-8V	Rc1/4	FW-20/20H, FF-10/20/20H, FA-2, FS-15/30
QEV-10V	Rc3/8	FW-40/40H, FF-40H, FA-40, FS-60/80N
QEV-15V	Rc1/2	FS-100HT, FS-80NT, FS-100NF

#### Pump controller/driver

The external solenoid valve is switched in response to signals from the built-in proximity sensors on each side of the bellows to ensure reliable operation of the pump. Two controller options are available along with one driver option.

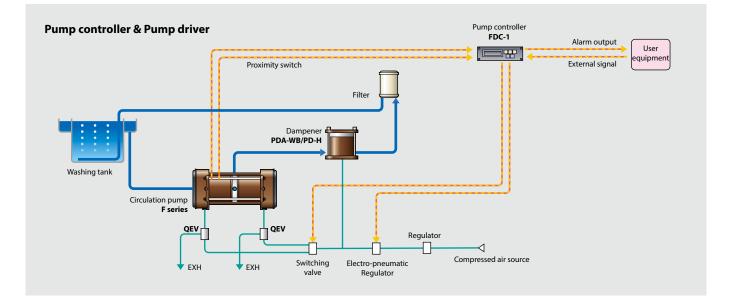
#### **Pump controller FDC-1**



discharge load varies due to increased filter resistance.

- The controller can monitor the flow rate, the number of strokes, and the total count.
- The unit operates either in the AUTO mode using external signals or in the MENU mode for manual control.
- The flow rate can be set at two different values as desired.
- In addition to the sensor mode using the proximity sensors, the timer mode is included as a standard feature. This enables continued pump operation in the timer mode in case of the failure of a proximity sensor.
- The unit is equipped with various alarm displays and output functions, including leak alarm and a pump malfunction alarm.

General specifi- cation	Power source	DC24V±10%
	Power consumption	24VA max.
	Ambient temperature	0 - 50°C
	Working atmosphere	Without corrosive gas in surrounding areas
Input specifica- tion	Start, Alarm reset	No-voltage contact or open collector Voltage ON: 3V maximum Voltage OFF: 18V maximum
Output specifi- cation (External out- put)	Pump malfunction alarm	Output form: NPN open collector Switching capacity: DC24V 0.4A
Dimensions	W158mm×D152mm×H48mm	



Dimension in mm

(272)

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(36

#### **Chemical replenishing system**

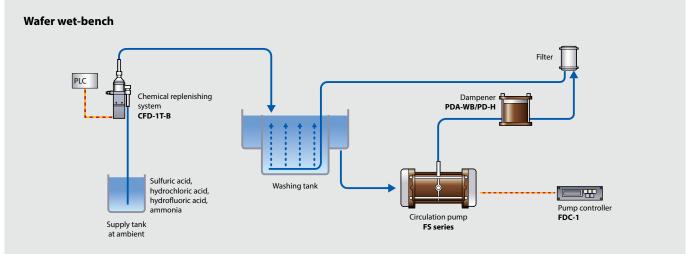
#### Chemical replenishing system CFD-1T-B

With a resolution of up to 1.0mL/shot fine dispense volumes can be achieved. 8mL type per shot is also available. Please contact us for details.

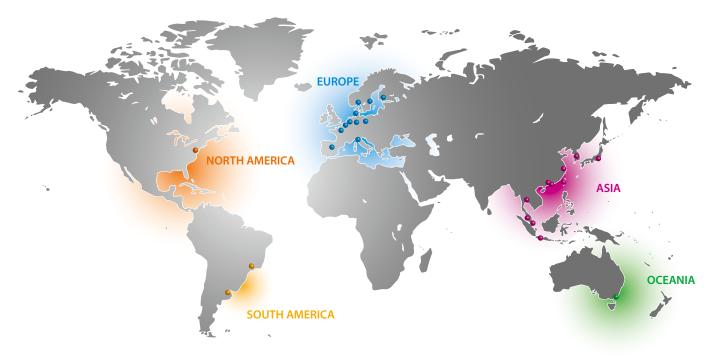
- The resolution of the CFD-1T-B has been greatly improved compared to our existing models. The minimum flow of 1mL/shot offers greater accuracy in chemical condensation control that is required in the wafer cleaning process. The CFD-1T-B always feeds the correct quantity of chemical without overshot eliminating excess liquid wastage. In addition, the anti-siphon mechanism prevents unintentional siphoning.
- The fluoroplastic wet end (PTFE, PFA, PCTFE) is capable of handling strong acids, alkalis and hydrogen peroxide, typical chemicals required for semiconductor processing. PTFE, PFA, PP, PVC external parts and PTFE coated screws provide additional protection against chemical attack from harsh environments.
- Adjustment of the stroke length to give between 1.0-2.7mL/shot is simple by removal of the bottom cover (Factory default is 1.0mL/shot).
- Every unit is equipped with a leakage sensor to immediately detect a leak.

Pump specification	Application		Chemical replenishing
	Discharge capacity	mL/shot	1
	Max. discharge pressure	MPa	0.05
	Liquid temperature range	°C	20 - 60
	Max. stroke speed	spm	30
	Max. supply air pressure	MPa	0.15 - 0.3
	Max. air consumption	NL/min	2.5
	Wet-end materials		PTFE, PFA, PCTFE
	Liquid port bore		1/4"PFA tube (Ø6.35ר4.35mm)
	Supply air port bore		Rc1/8
	Mass	kg	1.1
Photosensor specification	Product name		Transmission type micro photo sensor
	Power voltage		5 - 24V DC±10%
	Output mode		NPN transistor open collector
	Allowable current		50mA or below
	Cord		5m PVC four-core cable (Outer dia. 5.2mm) with 0.5 - round terminal









### IWAKI world-wide network

## **Manufacturing locations**

#### Iwaki's production system, namely quality assurance system

Thorough quality-control measures and constant pursuit of efficiency have helped IWAKI establish a superior production system.





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